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Substitute for form 1449A/PTO		SEP 20 2004		Application Number	10/023,125
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	December 17, 2001
(Use as many sheets as necessary)				First Named Inventor	Yoo, et al.
				Group Art Unit	1765
				Examiner Name	Unknown
				Attorney Docket Number	AMAT/5730/TCG/WCVD
Sheet	1	of	1	Submission Date	September 15, 2004

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
/F.S./	A1	6,635,965	10/21/2003	Lee, et al.	
	A2				
	A3				
	A4				
	A5				
	A6				RECEIVED
	A7				SEP 23 2004
	A8				
	A9				
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NON PATENT LITERATURE DOCUMENTS					
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/F.S./	C1	Yang, et al. "Atomic Layer Deposition of Tungsten Film from WF6/B2H6: Nucleation Layer for Advanced Semiconductor Device," Conference Proceedings ULSI XVII (2002) Materials Research Society.			

Examiner /Francis Smith/ Date Considered 12/18/2007

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